

# **2023 IEEE International Symposium on Inertial Sensors and Systems (INERTIAL 2023)**

**Lihue, Hawaii, USA  
28-31 March 2023**



**IEEE Catalog Number: CFP23YAL-POD  
ISBN: 978-1-6654-5148-2**

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IEEE Catalog Number:	CFP23YAL-POD
ISBN (Print-On-Demand):	978-1-6654-5148-2
ISBN (Online):	978-1-6654-5147-5
ISSN:	2377-3464

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